

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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### Title of Invention

METHOD AND STRUCTURE OF VERTICAL STRAINED  
SILICON DEVICES

Application Number :

Confirmation Number:

First Named Applicant: Kangguo Cheng

Attorney Docket Number: FIS920030221US1

Art Unit:

Examiner:

Search string: ( 6313486 or 6503833 or 6524935 or 5461243 or 5847419 or 6429061 or 5256550  
) .pn

### US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6313486	2001-11-06	Kencke, et al.			
	2	6503833	2003-01-07	Ajmera, et al.			
	3	6524935	2003-02-25	Canaperi, et al.			
	4	5461243	1995-10-24	Ek, et al.			
	5	5847419	1998-12-08	Imai, et al.			
	6	6429061	2002-08-06	Rim			
	7	5256550	1993-10-26	Laderman, et al.			

### Signature

Examiner Name	Date